

*2 Pre Amended A*  
7-22-01

Official Communication

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Selzer  
Application No.: 09/332,206  
Filing Date: June 12, 1999  
Title: Method of Improving X-Ray  
Lithography in the Sub 100nm  
Range to Create High Quality  
Semiconductor Devices

Docket No. 1520-006 (1426)  
Date: June 7, 2001  
Group Art Unit: 2876  
Examiner: I. Kiknadze  
FAX: 703 305-3594  
No. of pages sent: 7

**Amendment Under 37 CFR 1.111**  
**Preliminary Amendment**

Assistant Commissioner of Patents  
Washington, D.C. 20231

Sir:

This is a preliminary amendment for a divisional application of this case. Please amend this application as follows. A credit card payment form for the application fee is attached.

**CERTIFICATE OF MAILING**

I hereby certify that, on the date shown below, this correspondence is being:

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James M. Leas

Name

James M. Leas

Signature